(37 CFR 1.8(a))

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In Re Application Of: Allan Rosencwaig et al.

Serial No. **09/294,869**

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Group Art Unit 2877

Invention: OPTICAL INSPECTION EQUIPMENT FOR SEMICONDUCTOR WAFERS WITH PRECLEANING

TO THE ASSISTANT COMMISSIONER FOR PATENTS

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I certify that this document is being deposited on May 14, 2002 with the U.S. Postal Service as first class mail under 37 C.F.R. 1.8 and is addressed to the Assistant Commissioner for Patents, Washington, D.C. 20231.

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